(19) World Intellectual Property Organization

International Bureau





(43) International Publication Date 17 March 2005 (17.03.2005)

PCT

(10) International Publication Number WO 2005/024727 A2

(51) International Patent Classification7:

G06T 15/40

(21) International Application Number:

PCT/EP2004/052059

(22) International Filing Date:

6 September 2004 (06.09.2004)

(25) Filing Language:

English

(26) Publication Language:

English

(30) Priority Data: MI2003A 001719 8 September 2003 (08.09.2003)

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- (81) Designated States (unless otherwise indicated, for every kind of national protection available): AE, AG, AL, AM, AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH, CN, CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI,

GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE, KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD, MG, MK, MN, MW, MX, MZ, NA, NI, NO, NZ, OM, PG, PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM, TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM,

(84) Designated States (unless otherwise indicated, for every kind of regional protection available): ARIPO (BW, GH, GM, KE, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM, ZW), Eurasian (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM), European (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI, FR, GB, GR, HU, IE, IT, LU, MC, NL, PL, PT, RO, SE, SI, SK, TR), OAPI (BF, BJ, CF, CG, CI, CM, GA, GN, GQ, GW, ML, MR, NE, SN, TD, TG).

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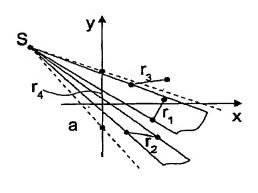
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- as to the applicant's entitlement to claim the priority of the earlier application (Rule 4.17(iii)) for the following designation US
- as to the applicant's entitlement to claim the priority of the earlier application (Rule 4.17(iii)) for the following designation US
- of inventorship (Rule 4.17(iv)) for US only

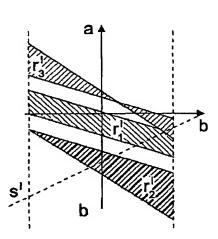
Published:

without international search report and to be republished upon receipt of that report

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(54) Title: METHOD FOR DETERMINING REFLECTIONS IN AN AREA.





(57) Abstract: The present invention refers to a method for determining reflections in complex environments, by means of ray tracing. For ray tracing it is necessary to determine the region of visibility between at least a first reflector and a second reflector by means of the following phases: representing said first and second reflector in a system of coordinates (x, y, z); said method is characterised in that it further comprises the phases of. carrying out an affine transformation of said system of coordinates (x, y, z); determining the region of visibility of said second reflector in relation to said first reflector as the set of the parameters of the straight lines that link a generic point of said first reflector with a generic point of said second reflector.





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